	Application No.	Applicant(s)	$\rightarrow$
Notice of Allowability	10/082,433	LOPATIN ET AL.	
	Examiner	Art Unit	
	Robert R. Koehler	1775	
The MAILING DATE of this communication All claims being allowable, PROSECUTION ON THE MERIT herewith (or previously mailed), a Notice of Allowance (PTOL NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATEN of the Office or upon petition by the applicant. See 37 CFR 1. \( \sum \) This communication is responsive to applicants' Amer	S IS (OR REMAINS) CLOSED in L-85) or other appropriate commu IT RIGHTS. This application is s L.313 and MPEP 1308.	nthis application. If not included unication will be mailed in due coustible to withdrawal from issue a	urse. <b>THIS</b> t the initiative
2. 🔀 The allowed claim(s) is/are <u>1-6,8-16 and 18-20</u> .			
3. $igotimes$ The drawings filed on $30$ June 2004 and 14 March 20	02 are accepted by the Examiner	r.	
4. Acknowledgment is made of a claim for foreign prior  a) All b) Some* c) None of the:  1. Certified copies of the priority documents  2. Certified copies of the priority documents  3. Copies of the certified copies of the priority International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:  Applicant has THREE MONTHS FROM THE "MAILING DAN noted below. Failure to timely comply will result in ABAND THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  5. A SUBSTITUTE OATH OR DECLARATION must be a INFORMAL PATENT APPLICATION (PTO-152) which including changes required by the Notice of Drafts  (a) including changes required by the Notice of Drafts  1) hereto or 2) to Paper No./Mail Date  (b) including changes required by the attached Exam Paper No./Mail Date  (b) noted by the attached Exam Paper No./Mail Date  (c) DEPOSIT OF and/or INFORMATION about the content of the paper No. Information of th	have been received. have been received in Application by documents have been received.  ATE" of this communication to file ONMENT of this application.  Submitted. Note the attached EXA gives reason(s) why the oath or must be submitted.  Sperson's Patent Drawing Review inner's Amendment / Comment or CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the in the header according to 37 CFR 1.84(c)) should be written on the interval of the	on No  Id in this national stage application  If a reply complying with the require  AMINER'S AMENDMENT or NOT  If declaration is deficient.  If (PTO-948) attached  If in the Office action of  the drawings in the front (not the back 1.121(d).  ERIAL must be submitted. Not	rements TICE OF
Attachment(s)  1. ☐ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-9)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO-Paper No./Mail Date  4. ☐ Examiner's Comment Regarding Requirement for Deport Biological Material	6. Interview St. Paper No./ /SB/08), 7. Examiner's	formal Patent Application (PTO-1 ummary (PTO-413), 'Mail Date Amendment/Comment  Statement of Reasons for Allowa Continuation Sheet.  ROBERT R. KOEHLEF PRIMARY EXAMINER ART UNIT 1775	ance

U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04)

**Notice of Allowability** 

Part of Paper No./Mail Date 07132004

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#### **DETAILED ACTION**

# Informal Examiner's Amendment

By way of this informal Examiner's amendment, the following changes have been entered in paragraph [0001] on page 1 of the specification. All of the following changes were made by the Examiner in order to update the patent applications data. A marked-up copy of page 1 of the specification is also included with this Office action.

- A. In line 4 of the paragraph, delete the wording "(S/N to be assigned);" and insert in its place --(SN 10/081,074);--.
- B. In line 7 of the paragraph, delete the wording "(S/N to be assigned);" and insert in its place --(SN 10/082,432; Pat. No. 6,528,424);--.
- C. In line 10 of the paragraph, delete the wording "(S/N to be assigned);" and insert in its place --(SN 10/083,809; Pat. No. 6,660,633);--.
- D. In line 14 of the paragraph, insert the wording --Pat. No. 6,515,368;-- immediately after "10/016,410;".
- E. In lines 16 and 17 of the paragraph, delete the wording "(S/N to be assigned);" and insert in its place --(SN 10/084,563; Pat. No. 6,717,236);--.
- F. In line 20 of the paragraph, insert the wording --(Pat. No. 6,630,741)-- between "10/016,645" and the period (.).

### **Drawings**

The drawings were received on June 30, 2004. These drawings are acceptable.

## Allowable Subject Matter

Claims 1 to 6, 8 to 16, and 18 to 20 are allowed.

The following is an examiner's statement of reasons for allowance: The Examiner has given careful consideration to applicants' Amendment and Remarks filed on June 30, 2004, and believes that the prior art of record does not teach, suggest, or disclose applicants' amended

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claims to a method of fabricating a semiconductor device which includes the steps of forming a copper surface directly on a semiconductor substrate and forming an electroplated copperzinc alloy thin film on the copper surface wherein the copper-zinc alloy thin film completely covers the copper surface. Also, the Examiner believes that the prior art of record does not teach, suggest, or disclose applicants' amended claims to a semiconductor device having a reduced-oxygen copper-zinc alloy thin film wherein the semiconductor device comprises a semiconductor substrate having at least one copper surface formed thereon and wherein an electroplated, reduced-oxygen copper-zinc alloy thin film completely covers the at least one copper surface. Therefore, in view of applicants' Amendment and Remarks, the Examiner withdraws the rejection of all claims under 35 U.S.C. § 102(e).

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

#### Conclusion

Any inquiry concerning this communication or earlier communications from the Examiner should be directed to Robert Koehler whose telephone number is **(571) 272-1536**. The Examiner can normally be reached on Tuesday to Friday from 9:30 AM to 7:00 PM. The Examiner can also be reached on alternate Mondays.

If attempts to reach the Examiner by telephone are unsuccessful, the Examiner's supervisor, Deborah Jones, can be reached on **(571) 272-1535**. The fax phone number for the organization where this application or proceeding is assigned is **703-872-9306**.

Information regarding the status of an application may be obtained from the Patent
Application Information Retrieval (PAIR) system. Status information for published
applications may be obtained from either Private PAIR or Public PAIR. Status information for

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unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <a href="http://pair-direct.uspto.gov">http://pair-direct.uspto.gov</a>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at **866-217-9197** (toll-free).

ROBERT R. KOEHLER PRIMARY EXAMINER

Art Unit 1775 July 13, 2004